

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :
Won-suk Yang et al. : Group Art Unit: 2814
Application No. 09/313,659 : Examiner: Kalam, Abul
Filed May 18, 1999 : Confirmation No. 4199

METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE

REQUEST FOR P.T.O. ACTION

U.S. Patent and Trademark Office
E-FILING
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

Please advise the undersigned as to when issuance of a next action on the merits is expected in the above-identified application.

Respectfully submitted,
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Date: March 23, 2009